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Complete if Known Substitute for form 1449/PTO Application Number NYA Filing Date 9-30-03 INFORMATION DISCLOSURE First Named Inventor Gaetano Jr. et al. STATEMENT BY APPLICANT Art Unit NYA (Use as many sheets as necessary) **Examiner Name** NYA IT-03-005 Attorney Docket Number

Sheet 1 of 11 U. S. PATENT DOCUMENTS Examiner Cite No. **Publication Date** Name of Patentee or Pages, Columns, Lines, Where **Document Number** Relevant Passages or Relevant Figures Appear Initials\* MM-DD-YYYY **Applicant of Cited Document** Number-Kind Code<sup>2</sup> (\* known) <sup>US-</sup> 5553143 /J.W./ entire document Ross et al. 09-03-96 US- 2002/0091644A1 07-11-02 Wong et al. entire document US- 2002/0147922A1 10-10-02 Hartinger et al. entire document <sup>US-</sup> 5905860 05-18-99 entire document Olsen et al. US- 6513121B1 01-28-03 Serkowski entire document US- 6078909 06-20-00 Knutson entire document US- 4924378 05-08-90 Hershey et al. entire document US- 6510502B1 01-21-03 Shimizu entire document US- 5671412 09-23-87 Christiano entire document <sup>US-</sup> 5826011 10-20-98 Chou et al. entire document <sup>US-</sup> 5790664 Coley et al. entire document 08-04-98 US- 5724425 Chang et al. 03-03-98 entire document US- 2002/0072983A1 Teller 06-13-02 entire document US- 6009401 12-28-99 Horstmann entire document us- 6023766 02-08-00 Yamamura entire document US-6169976B1 01-02-01 Colosso entire document US- 6233567B1 Cohen 05-15-01 entire document US- 6460140B1 10-01-02 Schoch et al. entire document US- 2002/0138764A1 entire document 09-26-02 Jacobs et al.

FOREIGN PATENT DOCUMENTS									
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